Search Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/695,046	PARSCHE	
Examiner	Art Unit	
Shih-Chao Chen	2821	

SEARCHED				
Class	Subclass	Date	Examiner	
343	700MS, 732, 830, 767, 866,867	5/3/2005	CHEN	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NO (INCLUDING SEARCI		)
	DATE	EXMR
EAST (See attached printout).	5/3/2005	CHEN